

09/463643

428 Rec'd PCT/PTO 25 JAN 2000

PATENT

Attorney Docket No.: NICHIA-00700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#5/IDS

T. Feaster

7/19/00

In re Application of:

) Group Art Unit:

Shuji Nakamura *et al.*

) Examiner:

Serial No.:

) INFORMATION DISCLOSURE
) STATEMENT

Filed: January 25, 2000

) 260 Sheridan Avenue, Suite 420

For: **NITRIDE SEMICONDUCTOR
DEVICE**) Palo Alto, California 94306
) (650)833-0160Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

The citations listed below, copies attached, may be material to the examination of the above-identified application, and are therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

Applicants have become aware of the following printed publication which may be material to the examination of this application:

- Japanese publication number 9-116130.


This Information Disclosure Statement under 37 C.F.R. §§ 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that anyone or more of these citations constitutes prior art.

Respectfully submitted,

HAVERSTOCK & OWENS LLP

Dated: January 25, 2000

By:



Thomas B. Haverstock

Reg. No.: 32,571

Attorneys for Applicants

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